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CONFIRMATION NO. 7521

SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.		
10/549,938	01/03/2007	438	2895	1592-0169PUS1		
RULE						
APPLICANTS Takashi Ozaki, Toyama, JAPAN; Kazuhiro Yuasa, Toyama, JAPAN; Kiyohiko Maeda, Toyama, JAPAN; ** CONTINUING DATA ***** This application is a 371 of PCT/JP04/12214 08/25/2004 ** FOREIGN APPLICATIONS ***** JAPAN 2003-301982 08/26/2003 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 03/30/2007						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input type="checkbox"/> Met after Allowance	STATE OR COUNTRY	SHEETS DRAWINGS	TOTAL CLAIMS	INDEPENDENT CLAIMS
Verified and /CARIDAD EVERHART/	Examiner's Signature	Initials	JAPAN	21	24	1
ADDRESS BIRCH STEWART KOLASCH & BIRCH PO BOX 747 FALLS CHURCH, VA 22040-0747 UNITED STATES						
TITLE Producing method of semiconductor device and substrate processing apparatus						
FILING FEE RECEIVED 2800	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees			
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